

Notice of References Cited	Application/Control No. 10/671,966		Applicant(s)/Patent Under Reexamination SCHNEIDER ET AL.	
	Examiner MICHELE C. CHOI		Art Unit 2164	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,374,271	04-2002	Shimizu et al.	715/207
*	B	US-6,154,600	11-2000	Newman et al.	386/4
*	C	US-2004/0054627 A1	03-2004	Rutledge, David R.	705/050
*	D	US-6,570,587 B1	05-2003	Efrat et al.	715/723
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.